

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/598,502 Confirmation No. 6549  
Applicant : Yuichiro Nakamura et al.  
371 Filed : September 1, 2006  
Art Unit : 1793  
Examiner : Mark L. Shevin  
Customer No. : 00270  
Title : SPUTTERING TARGET WITH FEW SURFACE DEFECTS,  
AND SURFACE PROCESSING METHOD THEREOF

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment filed in response to a non-final Office Action dated November 12, 2008. A Petition for a One Month Extension of Time is being filed herewith to extend the deadline for response from February 12, 2009 to March 12, 2009. Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.